IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT

Applicant(s):	JANGJIAN, Shiu-Ko, et al.	**Docket No.:**	39524.8100
Serial No.:	10/679,764	**Group Art Unit:**	1762
Filed:	October 6, 2003	**Examiner:**	David P. Turocy
Title:	**METHOD OF FORMING INTER-METAL DIELECTRIC LAYER STRUCTURE**	**Confirmation No.:**	8562

AMENDMENT AND RESPONSE TO OFFICE ACTION

Dear Sir:

In response to the Office Action mailed March 4, 2008, in connection with U.S. Patent Application No. 10/679,764, please consider the amendments and the remarks set forth below.

Amendments to the specification begin on page 2 of this paper.

Amendments to the Claims as reflected in the listing of claims, begin on page 3 of this paper.

Remarks begin on page 6 of this paper.